



P/4178-9

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Masanobu SATO et al.

Date: July 14, 2005

Serial No.: 10/669,520

Group Art Unit: 1734

Filed: September 24, 2003

Examiner: Yewebdar T. Tadesse

For: SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING SYSTEM

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL SUBMISSION

Sir:

A typographical error has been noticed in the Submission dated June 23, 2005.

Enclosed is a corrected Applicant's Art Citation form in which Document No.

US-2001/0037858 has been entered correctly.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on July 14, 2005

James A. Finder

Name of applicant, assignee or
Registered Representative

Signature

July 14, 2005

Date of Signature

Respectfully submitted,

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Enclosures

APPLICANT'S ART CITATION (Use several sheets if necessary)		Application 10/669,520		OFGS File No. P/4178-9			
		Applicant Masanobu SATO et al.					
		Filing Date September 24, 2003		Group Art Unit 1734			
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
	US-2001/0037858	11-2001	Taniyama et al.	156	345		
	US-						
	US-						
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
Examiner		Date Considered					
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							